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TRANSMITTAL OF FORMAL DRAWINGS

Docket No.
YOR920030478US1 (17032)

In Re Application Of: **Stephen W. Bedell, et al.**

Application No.	Filing Date	Confirmation No.	Examiner	Customer No.	Group Art Unit
10/664,714	9/18/2003	4400	J.A. Garcia	23389	2823

Invention: **METHOD OF IMPROVING THE QUALITY OF DEFECTIVE SEMICONDUCTOR MATERIAL**

Address to:
**Commissioner for Patents
P.O. Box 1450
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Transmitted herewith are:

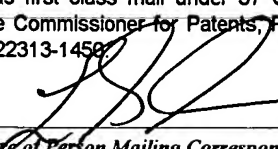
4 sheets of formal drawing(s) for this application.

☒ Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c).


Signature

Dated: **August 31, 2004**

**Leslie S. Szivos, Ph.D.
Registration No. 39,394**

I certify that this document and attached formal drawings are being deposited on 8/31/2004 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.
 <i>Signature of Person Mailing Correspondence</i>
Leslie S. Szivos, Ph.D. <i>Typed or Printed Name of Person Mailing Correspondence</i>